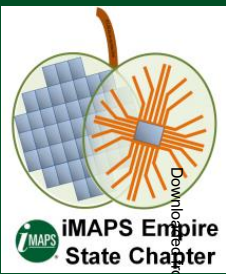




IMAPS 12th International Conference and Exhibition on Device Packaging

Assembly and Packaging Society

**12th International Conference and Exhibition on
Device Packaging**



Emerging Flux Challenges for BGA Packages

Maria Durham

Technical Support Engineer

SzePei Lim

Asia Product Manager

Dr Andy Mackie

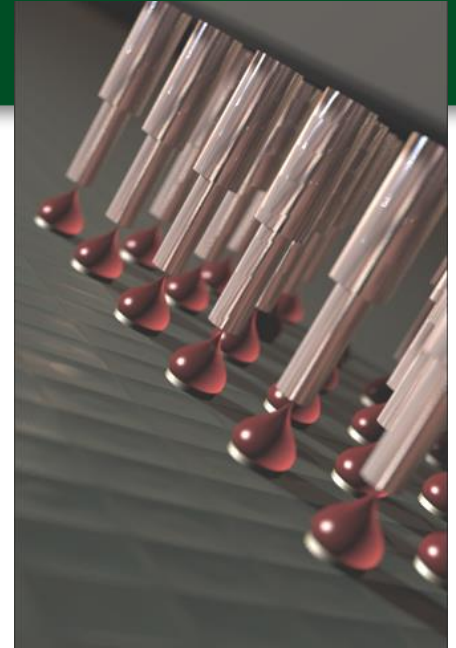
Senior Product Manager

Jason Chou

Area Technical Specialist (Taiwan)

Challenges

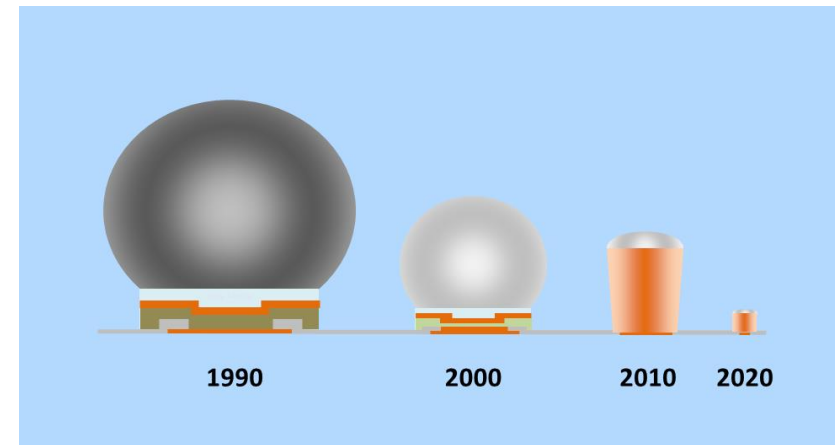
- **Halogen-free**
- “One step” BGA reflow
- BGA flux key performance parameters



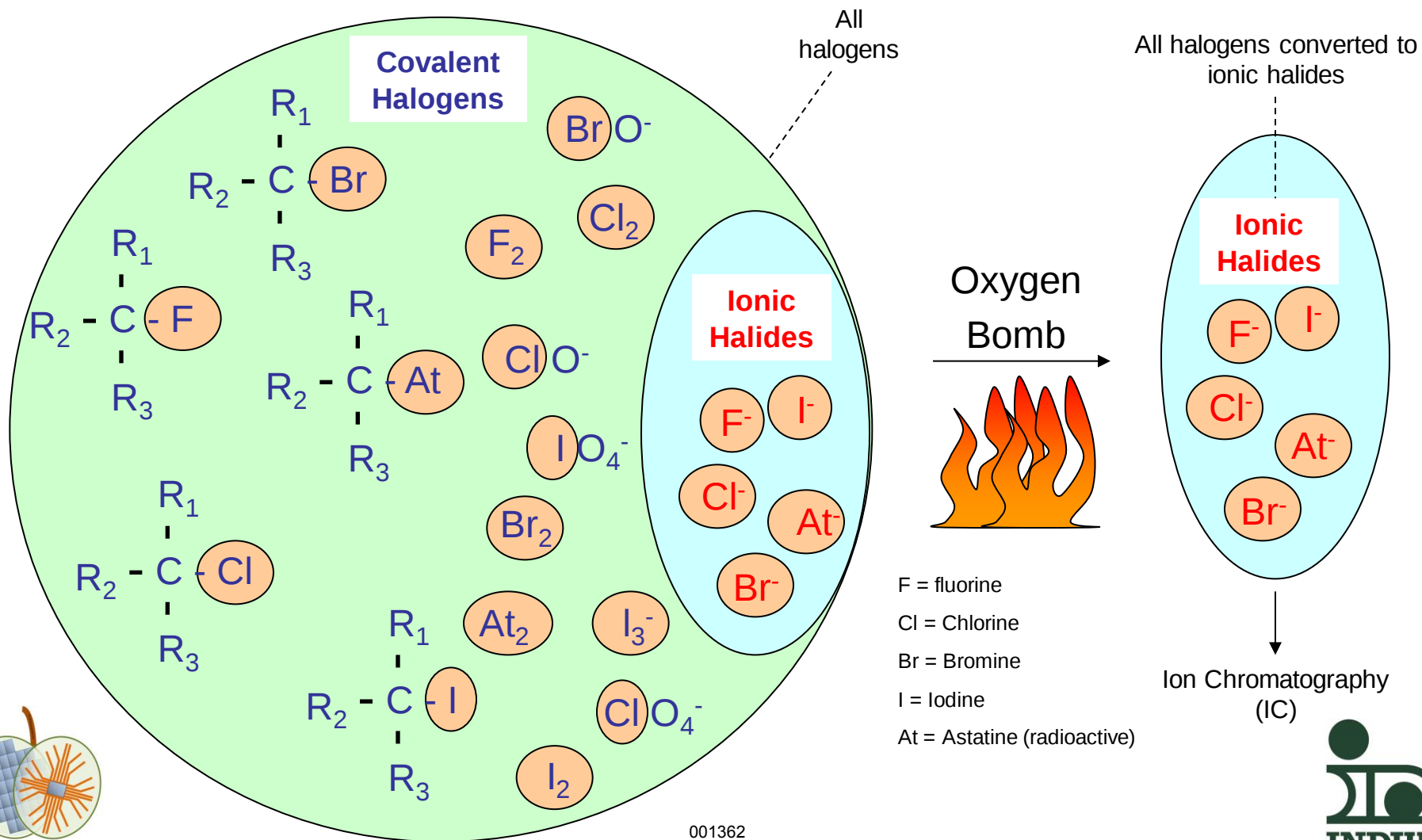
Halogen-free Drivers

- **Environmental Legislation and Industry Standards:**
 - RoHS
 - IEC 61249-2-21
 - Specific halogenated compounds
- **Reliability**
 - IPC J-STD-005
 - Halides

Are IPC standards relevant to semiconductor packaging and SiP?



Why Halogen-free, not Halide-free?



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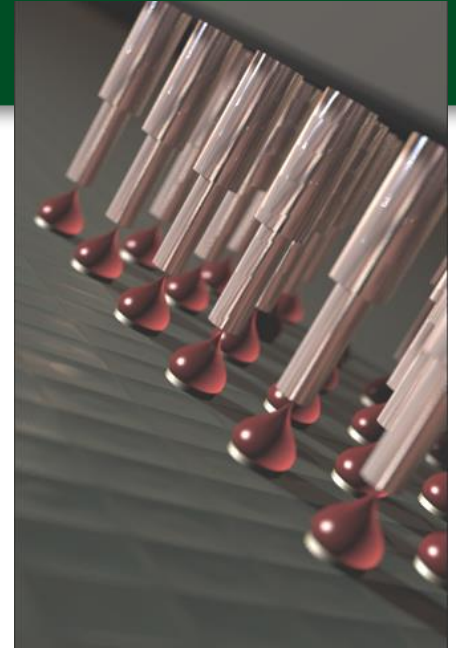
Halogen-Free: Three Level Approach

Analytical target				
Below :	150ppm	900ppm	1500ppm	
Above :	-	150ppm	900ppm	1500ppm
For individual Cl or Br :	Halogen-free (No intentionally Added: NIA)	Halogen-compliant	Halogen-compliant	Halogen-containing
For (Cl + Br) :	Halogen-free (No intentionally Added: NIA)	Halogen-compliant	Halogen-containing	Halogen-containing

“How do you quantify ‘Intent’?”

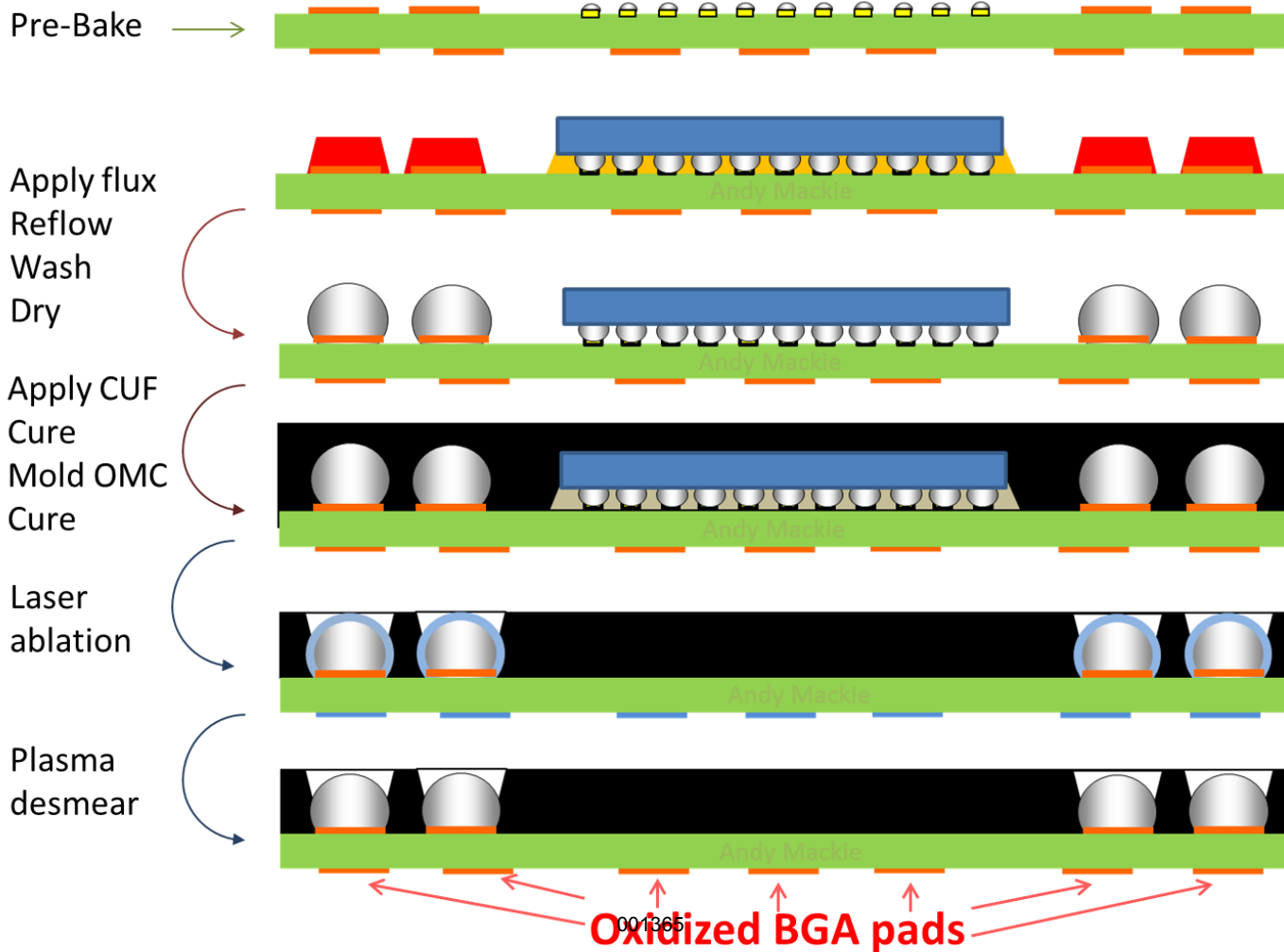
Challenges

- Halogen-free
- **“One step” BGA reflow**
- BGA flux key performance parameters

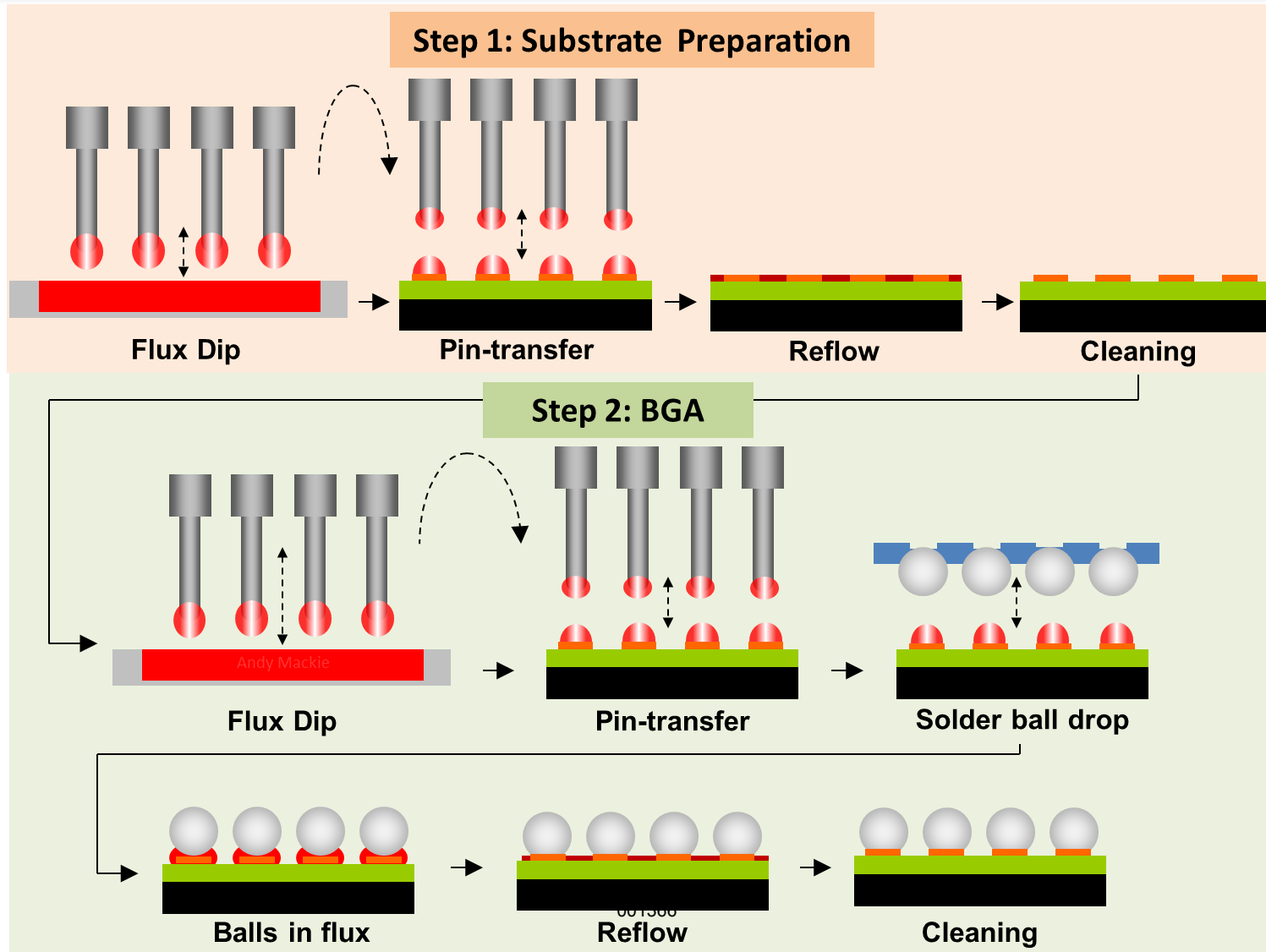


Processes Leading to OSP Degradation

FCBGA Substrate Treatment Before BGA Balling



Typical Two-Step BGA Ball-attach Process

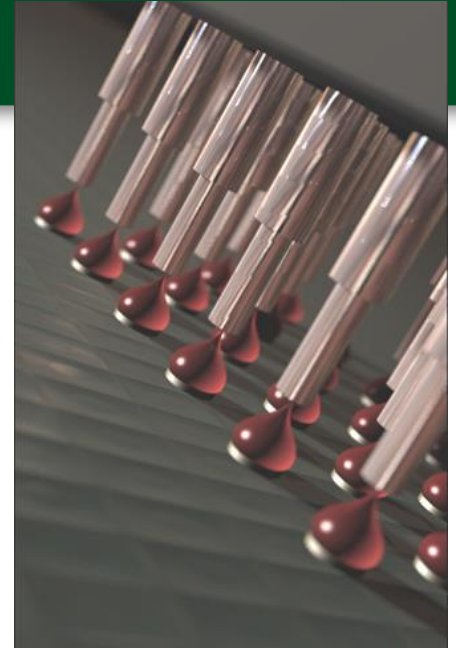


Goal: Eliminate Substrate Prep (Step 1)

- Increase UPH
- Reduce costs
- Reduce warpage

Challenges

- Halogen-free
- “One step” BGA reflow
- **BGA flux key performance parameters**



Ideal Flux for “One Step”

- **Good solderability (Joint strength)**
 - Unaffected by extreme copper-OSP substrate pretreatment
- **No missing ball**
 - No movement during reflow (MDR)
- **Long consistent usage life**
- **Cleanability**
 - Room temperature DI water

Ideal BGA Flux

- **Good solderability / No missing ball**
- Long consistent usage life
- Cleanability

Simulated Preconditioning of Substrates

- **Solder Spheres**
 - SAC305, 28mil
- **Reflow**
 - Soak (preheat) reflow profile
 - Air reflow
- **Substrates**
 - OSP substrates
- **Preconditioning**
 - None
 - Bake
 - 2hr bake @ 170C
 - 7hr bake @ 130C
 - Bake and Cleaner
 - 2hr bake @ 170C
 - Cleaned with aggressive aqueous flux cleaner @ 96C
 - 7hr bake @ 130C
 - Double Bake and Cleaner
 - 2hr bake @ 170C
 - Cleaned with aggressive aqueous flux cleaner @ 96C
 - 7hr bake @ 130C
 - 2hr bake @ 170C
 - Cleaned with aggressive aqueous flux cleaner @ 96C
 - 7hr bake @ 130C

Wetting and MDR* test method

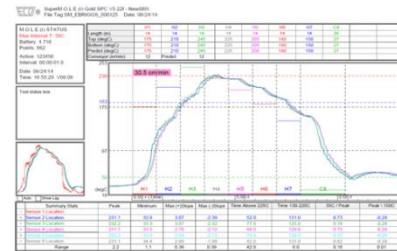
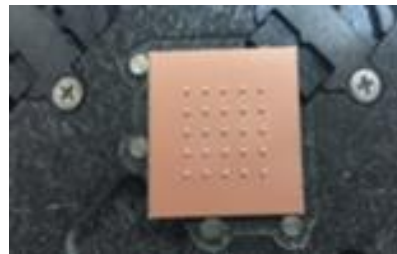
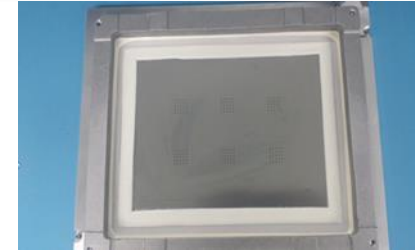
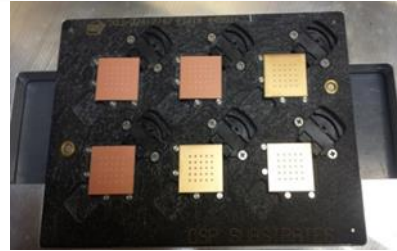
1. Print flux onto metallized surface
2. Place spheres onto flux deposit
3. Reflow

Wetting:

Calculate percent spread (wetting)

MDR:

Calculate mean sphere center movement



$$S_R = \frac{D-H}{D} \times 100 \quad (16)$$

where, S_R : spreading ratio (%)

H : height of the spread solder (mm)

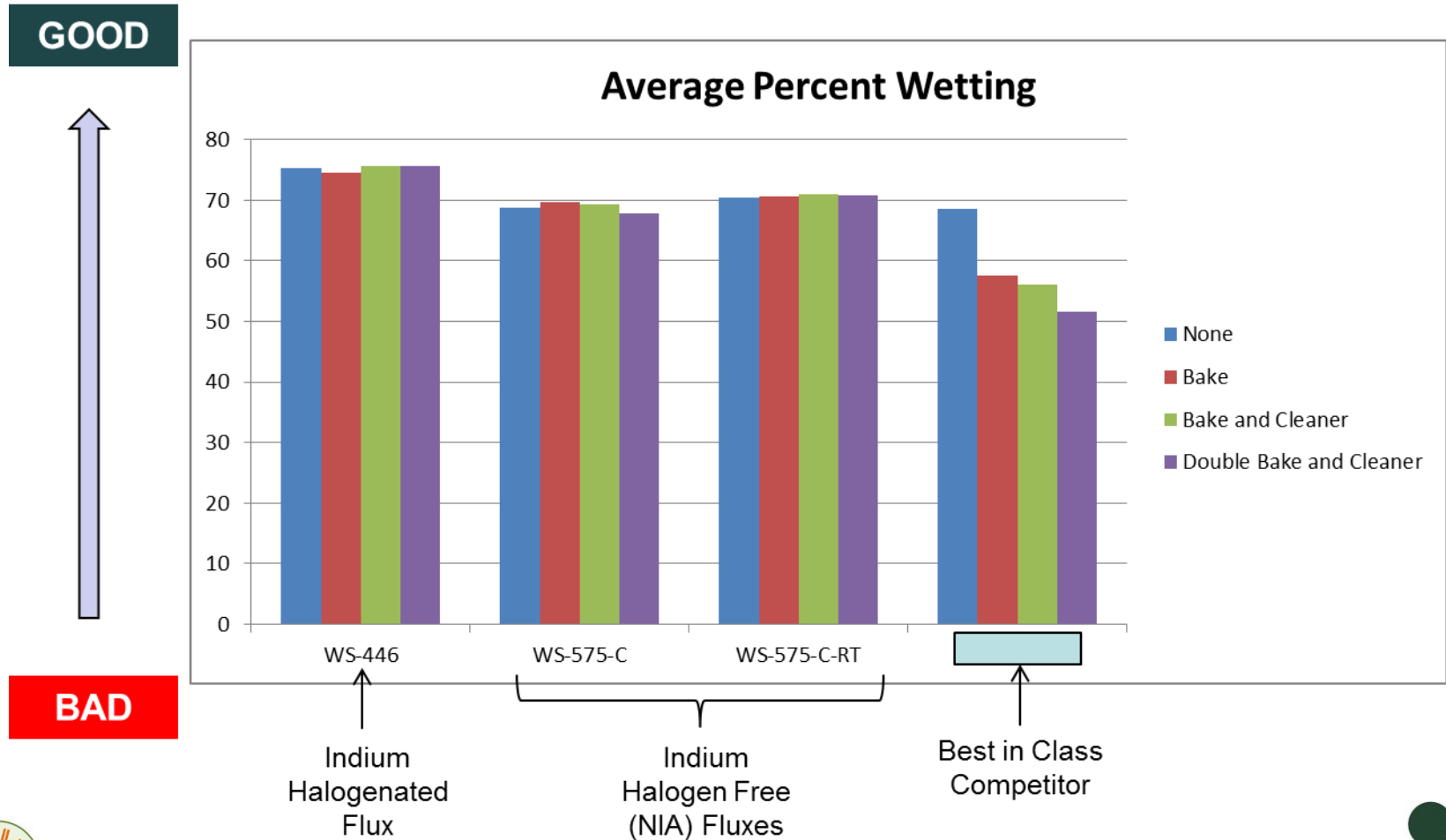
D : diameter of the solder, when it is assumed to be a sphere (mm)

$D = 1.24V^{1/3}$

V : mass⁽¹²⁾/density of tested solder

*Movement during reflow

Wetting Comparison



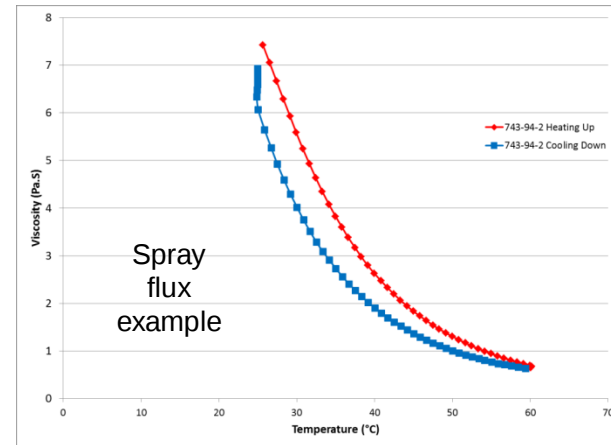
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Movement During Reflow

- **Flux viscosity**

- Less critical

- Room temperature viscosity

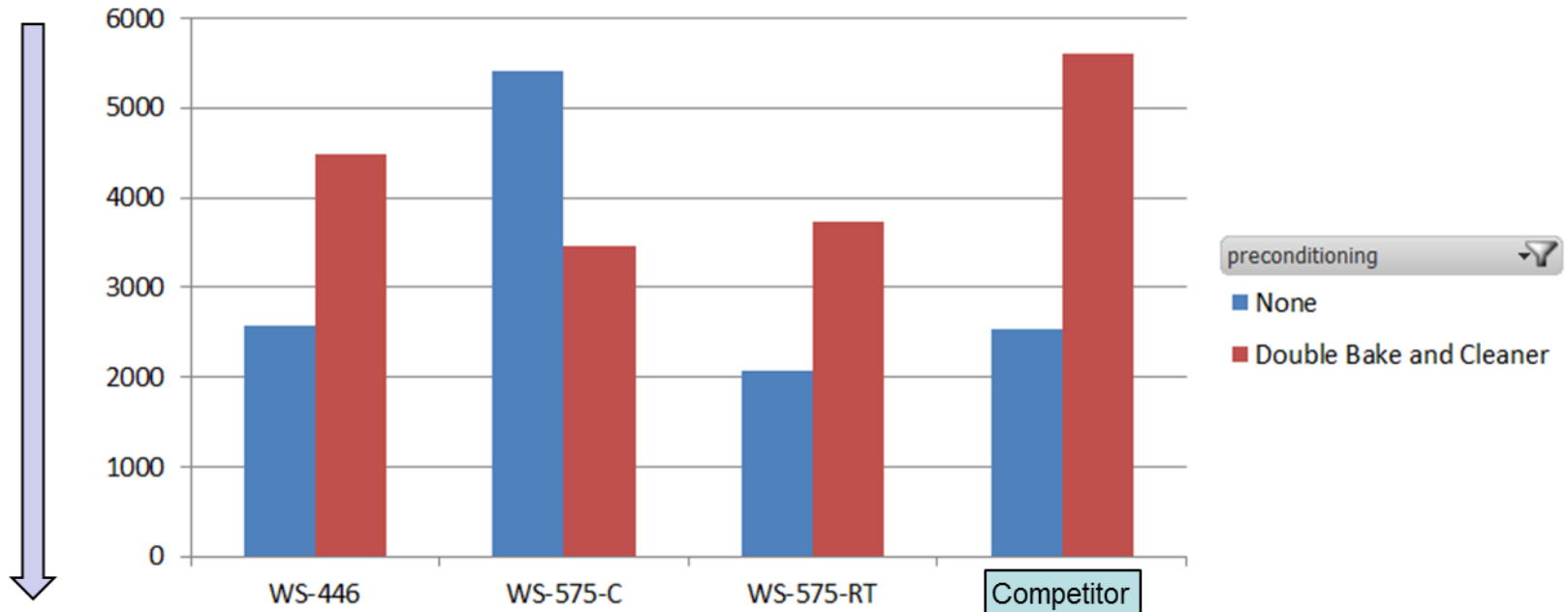


- **Solderability**

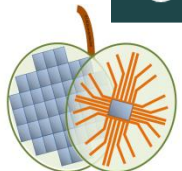
- Key: Early activation and reflow

Movement During Reflow (MDR)

BAD



GOOD



Ideal BGA Flux

- Good solderability / No missing ball
- **Long consistent usage life**
- Cleanability

Materials Lifetime by Usage Type

					By Application: May also be called...		
Proposed Name			Container Opened?*	Description: "How long the material will still be useable in its application..."	Printing	Dipping	Dispense
Material Life	Shelf-life	Andy Mackie	No	..under the recommended storage conditions"	Shelf-life		
	Floor-life		No	...after sealed container is warmed up to ambient after cold storage"	Unrefrigerated-life		
	Working-life	Exposure-life (tack + staging life)	Yes	...after being placed in the equipment (tool)"**	Print-life / Stencil-life	Pot-life / Dipping life	Dispense-life
	Tack-life		Yes	...after deposition and before component/die placement."	Open-time / Abandon time	[None? - placement usually immediate]	Open-time / Staging time
	Staging-life		Yes	...after component/die placement and before reflow."	Staging time	Open-time	
	Residue-life		Yes	...after reflow."	n/a		

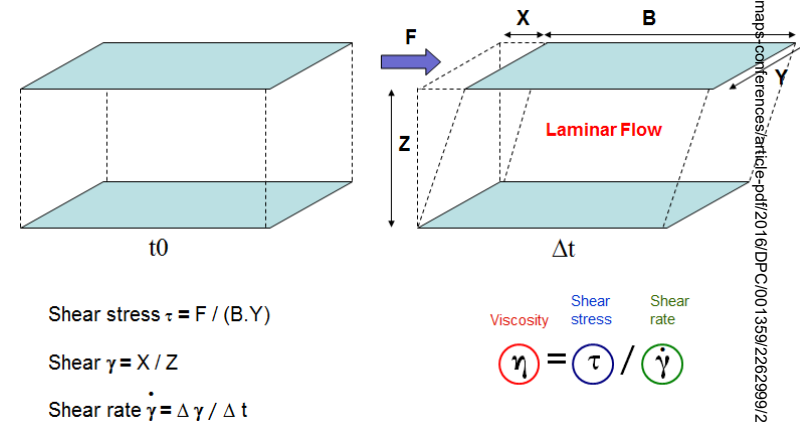
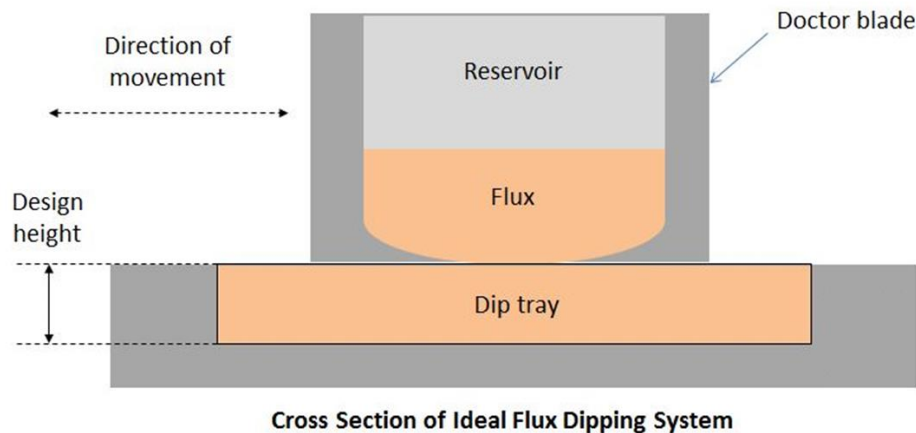
****Packages supplied by material manufacturer - and directly contacting material - opened or uncapped and material directly exposed to air**

Viscosity (t)

Tack (t)

001377

Rheology Measurements and Relation to Dipping

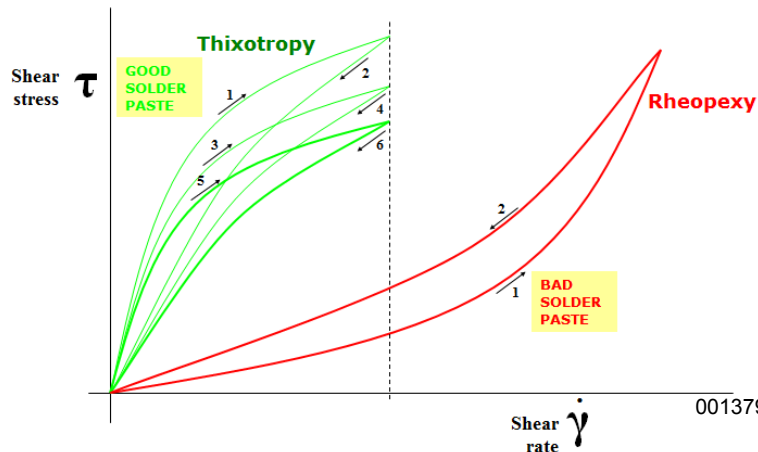


Movement speed / Design height =
Shear rate

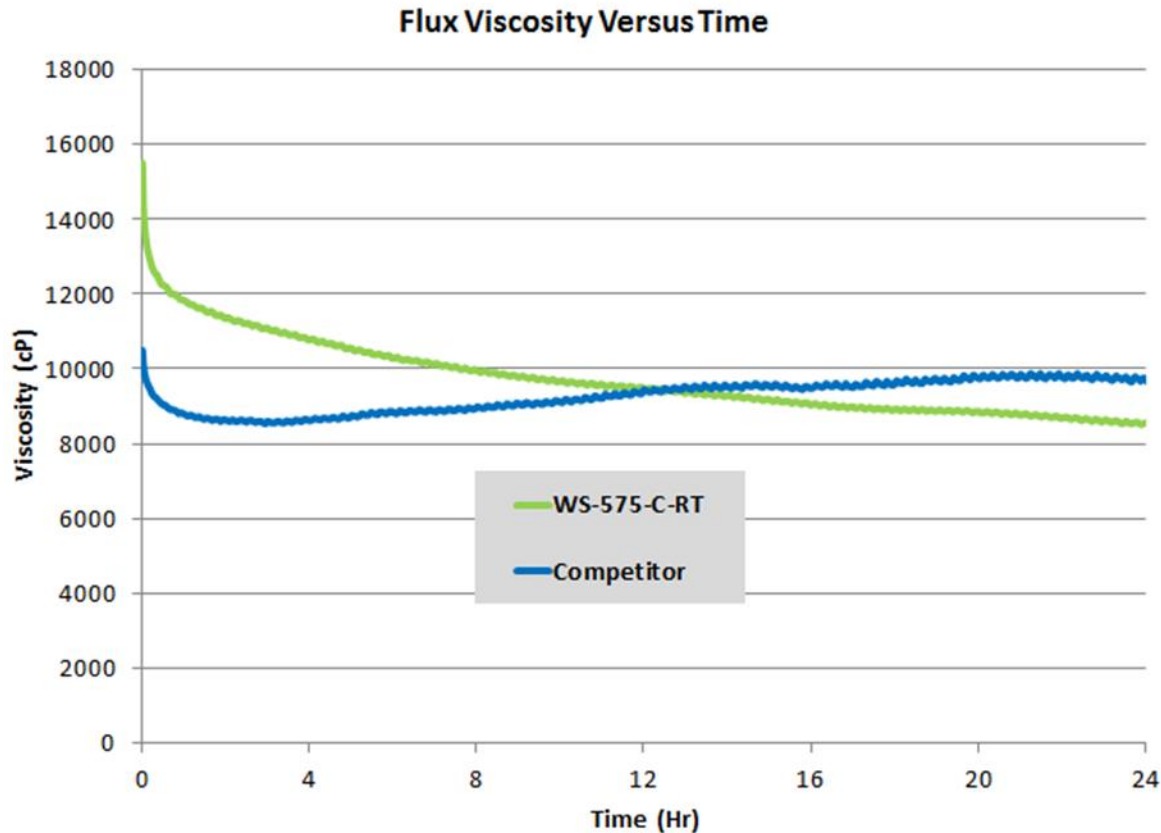
Viscosity Test Method

- **Equipment:**
 - Brookfield Cone and Plate
 - Model: DV3THBCB
- **Parameters:**
 - Spindle: CP-51
 - Temperature: 25°C
 - RPM's: 20 RPM (50/s)

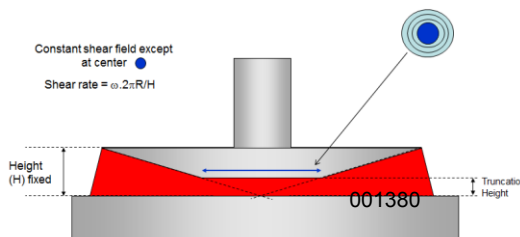
Viscosity is just one aspect of rheology



Comparative Viscosities as a Function of Time



**Stable
Viscosity**

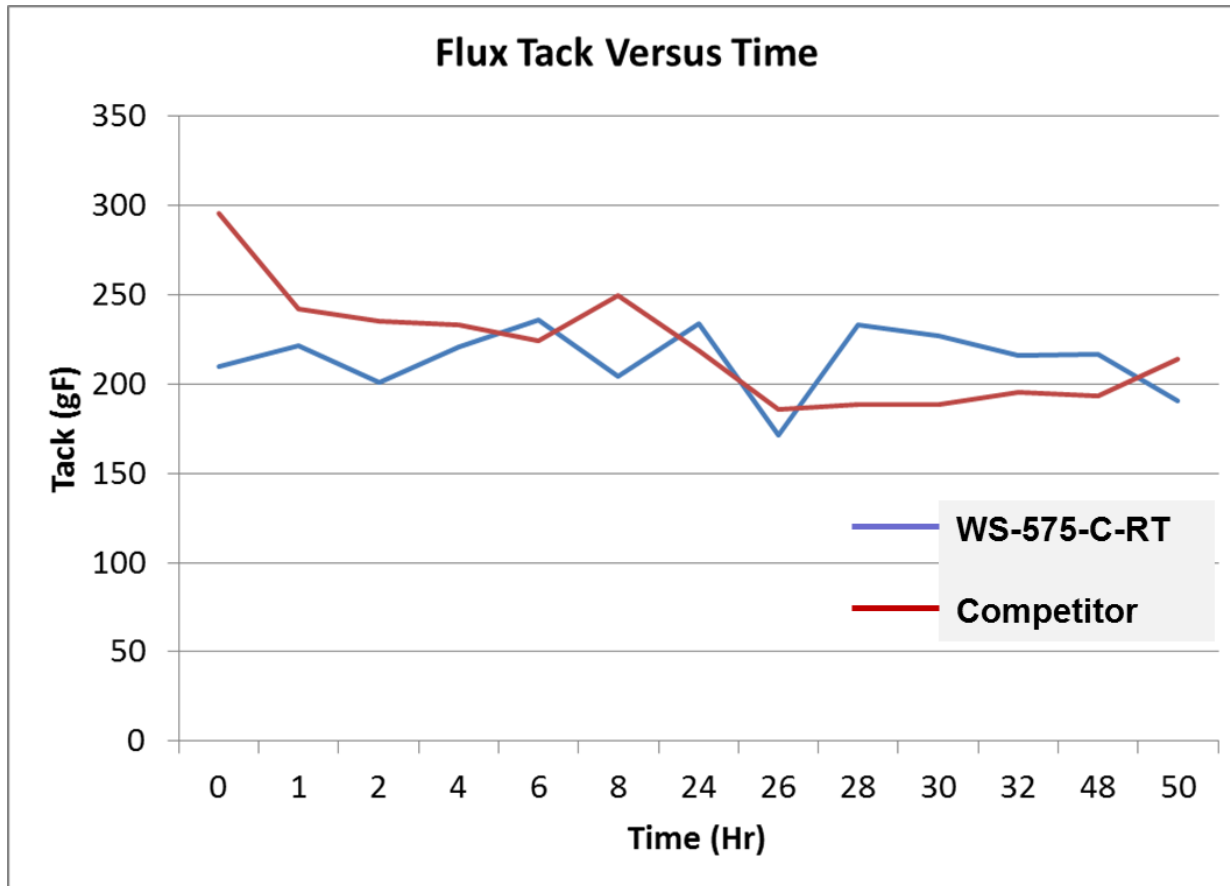


Tack Test Method

- **Equipment**
 - Texture Technologies TA.XT2
- **Parameters**
 - Ambient Conditions
 - Humidity: $50\% \pm 3\%$
 - Room Temperature: $21.5^{\circ}\text{C} \pm 2^{\circ}\text{C}$



Comparative Tack as a Function of Time



**Stable
Tack**

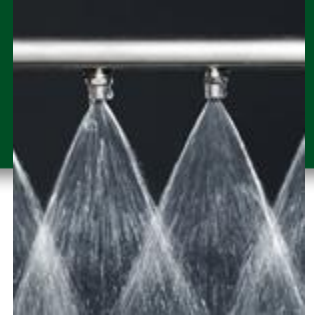
Ideal BGA Flux

- Good solderability / No missing ball
- Long consistent usage life
- **Cleanability**

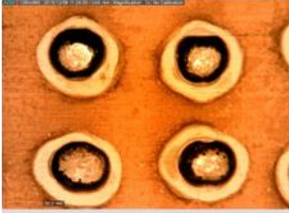
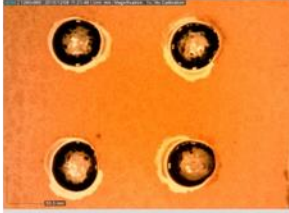
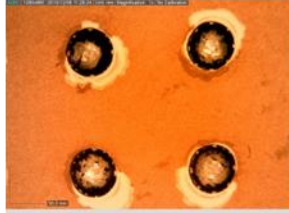
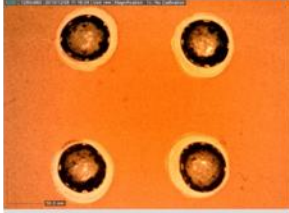
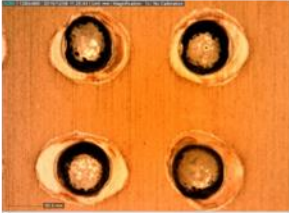
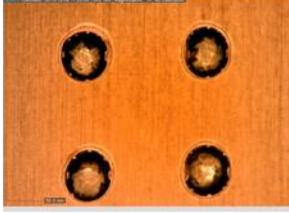
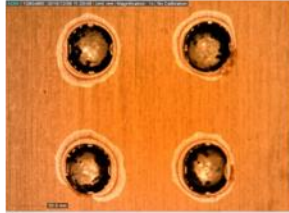
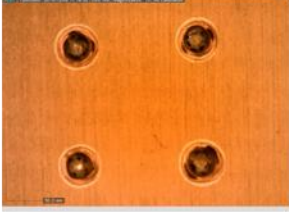
Cleaning Test

- **Very mild (forcing) condition**

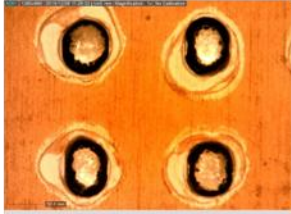
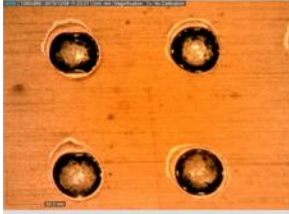
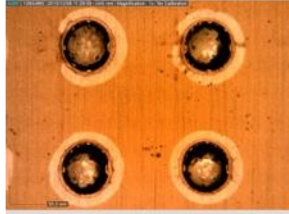
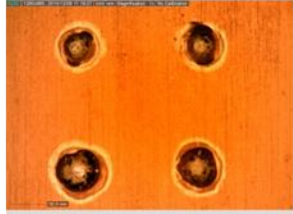
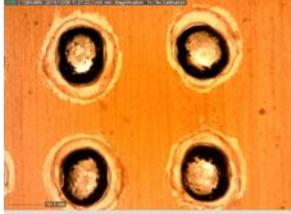
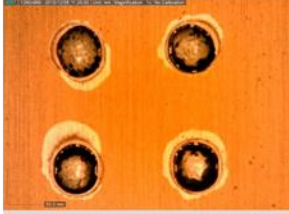
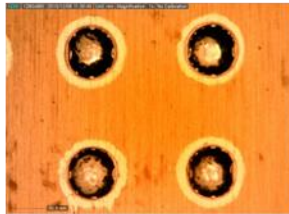
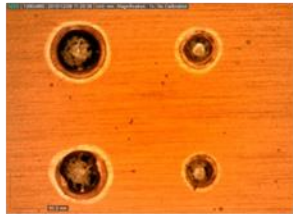
- Deionized water temperature: 36°C
- Deionized water conductivity $\leq 1.00 \mu\text{S}/\text{cm}$
- Zero Pressure
- Flow rate 5cc/minute
- Time of cleaning: 1 minute



Cleaning on OSP Substrates

	WS-446	WS-575-C	WS-575-C-RT	Competitor
Bare OSP				
Baked OSP				

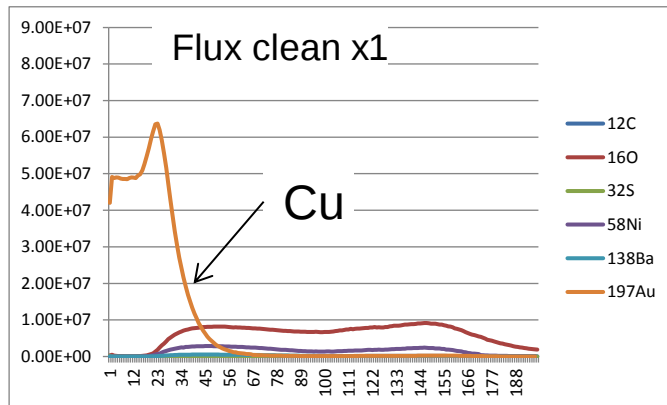
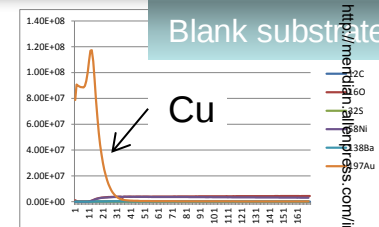
Cleaning on OSP Substrates

	WS-446	WS-575-C	WS-575-C-RT	Competitor
Baked and Cleaner OSP				
	WS-446	WS-575-C	WS-575-C-RT	Competitor
Double Baked and Cleaner OSP				

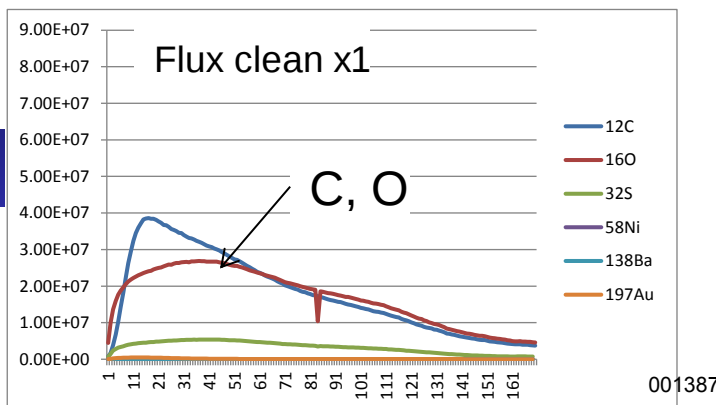
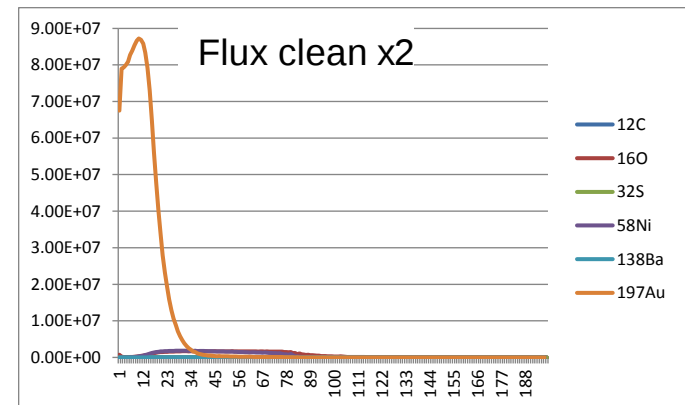
Cleanability: SIMS Analysis on Real Product

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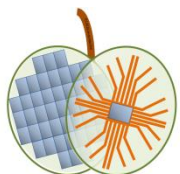
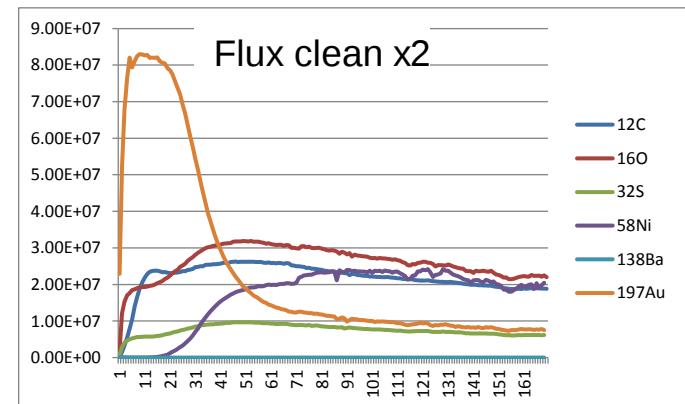
- ❑ The sample processes through full process –SMT/ Die Wire bond/ Molding.
- ❑ WS575-C SIMS element analysis show WS575-C can clean the surface as clean as bare substrate. While the competitor still has C, O after 1 time flux clean.



WS575-C



Competitor

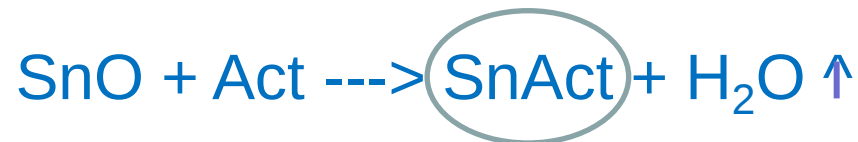


iMAPS Empire
State Chapter



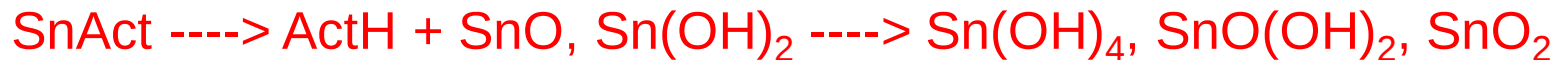
Problem: White Residue (Tin Oxide) Observed on Substrate

Reflow reaction:



Tin/activator salt dissolves into flux residues,
away from the metal surface

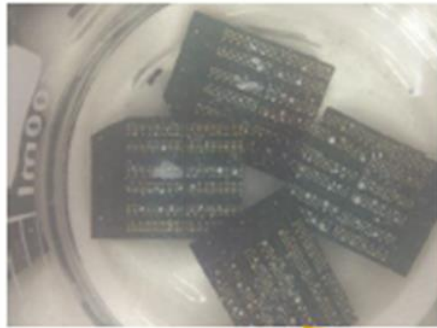
Cleaning: Hydrolysis reaction:



Rate
affected by
temperature

001388

Effect of DI Water Cleaning Temperature



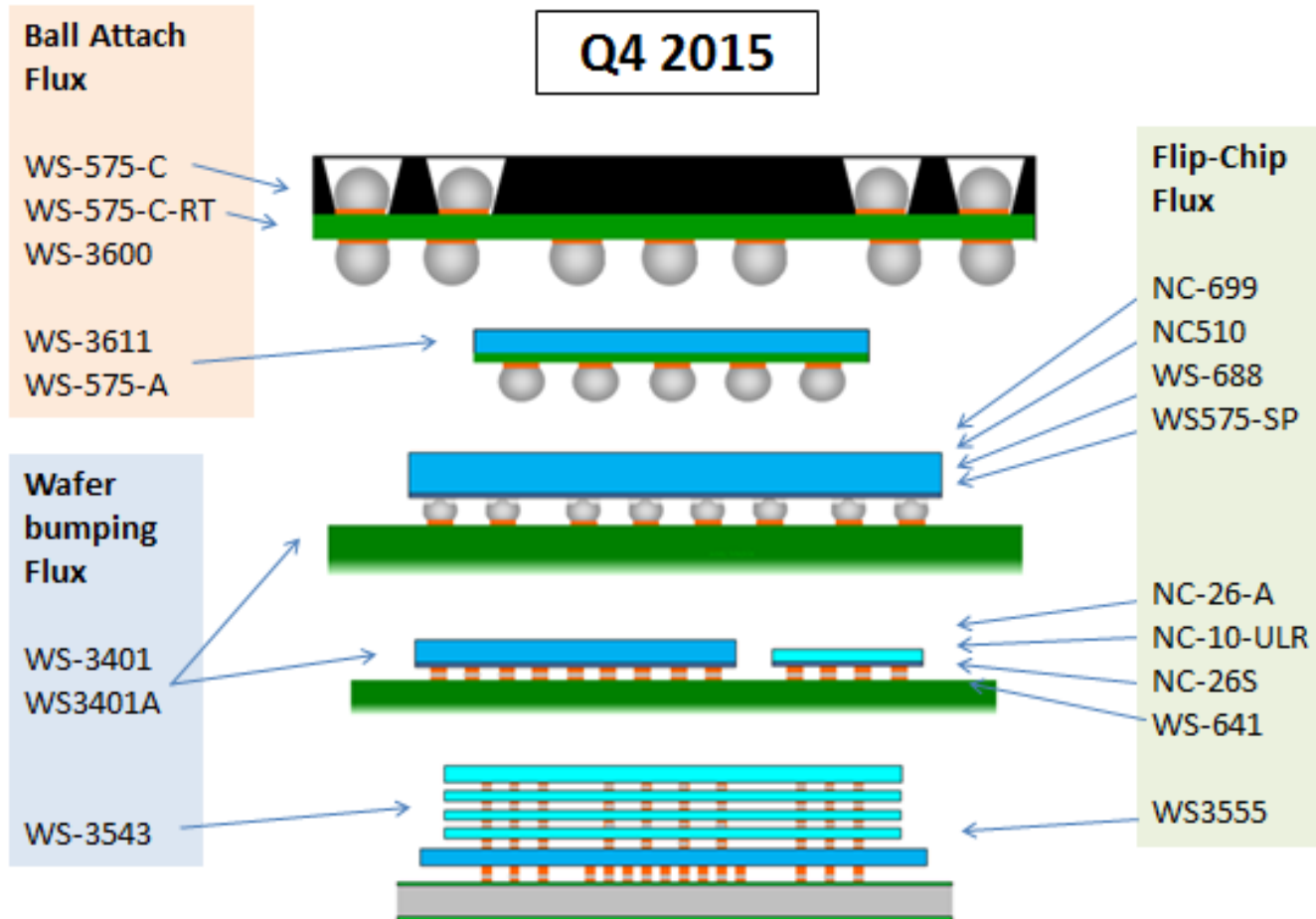
60C show white residue



25C is clear –
no white residue

**Customer
reduced
water
temperature
to eliminate
white
residues
∴ Cost
saving**

Thank you!



*Note: Examples of customer usage only.
Some fluxes have multiple uses*



References
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